## **TRANSMITTAL**

## Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	[SEMICONDUCTOR DEVICE AND FABRICATING METHOD THEREOF]	
Application Number	Application Number :	
Date :		
First Named Applica	Mr. Yu-Piao Wang	
Confirmation Numbe	r:	
Attorney Docket Nun	nber: 11417-US-PA	

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Submitted By:	Elec. Sign.	Sign. Capacity
Dr. Belinda Lee	/Belinda Lee/	Agent
Registered Number: 46,863		

Documents being submitted:	Files
us assignment	11417-usassn.xml
us-assignment	us-assignment.xsl
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## Comments

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